



JPW

Docket No.: R2184.0162/P162-A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Miho Okazaki

Application No.: 10/798,356

Art Unit: 2815

Filed: March 12, 2004

Examiner: A. R. Wilson

For: SEMICONDUCTOR APPARATUS WITH
IMPROVED ESD WITH STANDING
VOLTAGE

AMENDMENT

MS Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action mailed September 27, 2004 (Paper No. 0904),
please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins
on page 3 of this paper.

Remarks begin on page 5 of this paper.